Special Issue

Low Temperature Plasma Jets: Physics, Diagnostics and Applications

Message from the Guest Editor

This Special Issue aims to provide a collection of papers on the fundamental aspects as well as applications of non-thermal plasma jets. These include diagnostics of the jet themselves, their interactions with surfaces, and their use in various industrial and scientific applications. Topics include (but are not limited to):

- Experimental measurements of the various jet parameters (electric field, charge density, reactive species concentrations, etc.)
- Interaction of jets with conducting and dielectric surfaces and with liquids
- Interaction of jets with each other
- Material processing (deposition, etching, ashing, etc.)
- Chemical applications
- Biological applications
- Medical applications

Guest Editor

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Deadline for manuscript submissions

closed (1 September 2019)



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Message from the Editor-in-Chief

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